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PATENT

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Denise Sheridan
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 09/970,100

Confirmation No. : 2699

Applicants : Vishnu K. Agarwal et al.

Attorney Docket No.: 500453.04 (29113/US/3)

Filed : October 2, 2001

Customer No. : 27,076

Art Unit : 1762 ✓

Examiner : William P. Fletcher III

Title : POLISHING PADS AND PLANARIZING MACHINES FOR MECHANICAL OR
CHEMICAL-MECHANICAL PLANARIZATION OF MICROELECTRONIC-DEVICE
SUBSTRATE ASSEMBLIES, AND METHODS FOR MAKING AND USING SUCH
PADS AND MACHINES

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Sir:

Applicant acknowledge receipt of the Office Action dated June 23, 2003.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Amendments to the Drawings begin on page 7 of this paper and include both attached replacement sheets and annotated sheets showing changes.

Remarks begin on page 8 of this paper.

An Appendix including amended drawing figures is attached following page 11 of this paper.